

Gen-Wen Hsieh

List of Publications by Year in descending order

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23
papers

1,324
citations

840776

11
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752698

20
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23
all docs

23
docs citations

23
times ranked

2891
citing authors

#	ARTICLE	IF	CITATIONS
1	Porous Polydimethylsiloxane Elastomer Hybrid with Zinc Oxide Nanowire for Wearable, Wide-Range, and Low Detection Limit Capacitive Pressure Sensor. <i>Nanomaterials</i> , 2022, 12, 256.	4.1	16
2	Enhanced piezocapacitive response in zinc oxide tetrapodâ€“poly(dimethylsiloxane) composite dielectric layer for flexible and ultrasensitive pressure sensor. <i>Nanoscale</i> , 2021, 13, 6076-6086.	5.6	22
3	Electrostatic polyester air filter composed of conductive nanowires and photocatalytic nanoparticles for particulate matter removal and formaldehyde decomposition. <i>Environmental Science: Nano</i> , 2020, 7, 3746-3758.	4.3	12
4	Graphene-induced enhancement of charge carrier mobility and air stability in organic polythiophene field effect transistors. <i>Organic Electronics</i> , 2018, 54, 27-33.	2.6	14
5	Germanium nanowire/conjugated semiconductor nanocomposite field effect transistors. <i>Organic Electronics</i> , 2018, 57, 269-276.	2.6	3
6	Electronic Transport and Light Response of Air-Stable n-Type Organic Chlorophenyl-Substituted Perylene Diimide Microribbons. <i>IEEE Transactions on Electron Devices</i> , 2017, 64, 2935-2941.	3.0	1
7	N-Channel Zinc Oxide Nanowire:Perylene Diimide Blend Organic Thin Film Transistors. <i>IEEE Journal of the Electron Devices Society</i> , 2017, 5, 367-371.	2.1	6
8	Dual layer semiconducting nanocomposite of silicon nanowire and polythiophene for organic-based field effect transistors. <i>Organic Electronics</i> , 2016, 35, 158-163.	2.6	7
9	Air-stable N-type organic microribbon transistors based on perylene diimides derivatives. , 2015, , .		0
10	Zinc Oxide Nanowire-Poly(Methyl Methacrylate) Dielectric Layers for Polymer Capacitive Pressure Sensors. <i>ACS Applied Materials & Interfaces</i> , 2015, 7, 45-50.	8.0	64
11	Stretched Contact Printing of One-Dimensional Nanostructures for Hybrid Inorganicâ€“Organic Field Effect Transistors. <i>Journal of Physical Chemistry C</i> , 2012, 116, 7118-7125.	3.1	25
12	Inkjet-Printed Graphene Electronics. <i>ACS Nano</i> , 2012, 6, 2992-3006.	14.6	1,018
13	Thin-film transistors based on poly(3,3â€“dialkyl-quarterthiophene) and zinc oxide nanowires with improved ambient stability. <i>Applied Physics Letters</i> , 2011, 98, 102106.	3.3	3
14	High performance nanocomposite thin film transistors with bilayer carbon nanotube-polythiophene active channel by ink-jet printing. <i>Journal of Applied Physics</i> , 2009, 106, .	2.5	40
15	Corrections to â€œZinc Oxide Nanostructures and High Electron Mobility Nanocomposite Thin Film Transistorsâ€“[Nov 08 3001-3011. <i>IEEE Transactions on Electron Devices</i> , 2009, 56, 156-156.	3.0	3
16	Zinc Oxide Nanostructures and High Electron Mobility Nanocomposite Thin Film Transistors. <i>IEEE Transactions on Electron Devices</i> , 2008, 55, 3001-3011.	3.0	46
17	Selective local synthesis of nanowires on a microreactor chip. <i>Sensors and Actuators A: Physical</i> , 2006, 130-131, 625-632.	4.1	17
18	Fabrication of individual aligned carbon nanotube for scanning probe microscope. <i>Journal of Physics: Conference Series</i> , 2005, 10, 186-189.	0.4	2

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19	Anodic bonding of glass and silicon wafers with an intermediate silicon nitride film and its application to batch fabrication of SPM tip arrays. <i>Microelectronics Journal</i> , 2005, 36, 678-682.	2.0	12
20	Selective carbon nanotube growth on silicon tips with the soft electrostatic force bonding and catalyst transfer concepts. <i>Nanotechnology</i> , 2005, 16, S296-S299.	2.6	5
21	Microstructuring characteristics of a chemically amplified photoresist synthesized for ultra-thick UV-LIGA applications. <i>Journal of Micromechanics and Microengineering</i> , 2004, 14, 1126-1134.	2.6	8
22	Selective local synthesis of nanowires on a microreactor chip. , 0, , .		0
23	A liquid-based gravity-driven etching-stop technique and its application to wafer level cantilever thickness control of AFM probes. , 0, , .		0